PATENT



The re application of: O'DONNELL

Attorney Docket No.: LAM1P133/P0582

Application No.: 09/472,757

Examiner: UMEZ ERONINI, Lynette T.

Filed: December 27, 1999

Group: 1765

Title: INSITU POST ETCH PROCESS TO REMOVE REMAINING PHOTORESIST AND RESIDUAL SIDEWALL PASSIVATION

**CERTIFICATE OF MAILING** 

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Box AF, Commissioner for Patents, Washington, D.C. 20231 on April 26,

Signed:

in Furchell

Sue Funchess

## AMENDMENT B TRANSMITTAL

Box AF Commissioner for Patents Washington, D.C. 20231

Sir:

Transmitted herewith is an Amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims After Amendment		Highest Previously Paid For	Present Extra	Small Entity Rate Fee	Large Entity Rate Fee
Total Claims	18	MINUS	20	0	x 9 =	x 18 = \$0
Independent Claims	3	MINUS	3	0	x 42 =	x 84 = \$0
Multiple Dependent Claim Present and Fee Not Previously Paid					\$140.00	\$280.00
				Total	· ·	\$0

Applicant(s) hereby petition for a \_\_\_\_\_ month extension(s) of time to respond to the aforementioned Office Action.

Applicant(s) believe that no (additional) Extension of Time is required; however, if it is determined that such an extension is required, Applicant(s) hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0388 (Order No. LAM1P133).

Enclosed is our Check No. \_\_\_\_\_ in the amount of \$\_\_\_\_ to cover the additional claim fee and/or extension of time fees.

Please charge the required fees, or any additional fees required to facilitate filing the enclosed response, to Deposit Account No. 50-0388 (Order No. LAM1P133).

Respectfully submitted,
BEYER WEAVER & THOMAS, LLR

Michael Lee

Deposit Account No. 31 846

P.O. Box 778 Berkeley, CA 94704-0778